



Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109716		APPLICATION NO. 09/857,569	
				APPLICANTS Masatake NAKANO et al.			
				FILING DATE June 7, 2001			
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)							
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1	5,494,849	02/27/1996	Iyer et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	2	JP A 11-026336 (abstract only)	01/29/1999	Japan			
	3	EP 0 451 993 A2	10/16/1991	Europe			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	4	M. Bruel et al., "Smart-Cut: A New Silicon On Insulator Material Technology Based on Hydrogen Implantation and Wafer Bonding", Jpn. J. Appl. Phys., Vol 36, 1997, pp 1636-1641					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: July 15, 2003

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Name of Applicant: Masatake NAKANO et al.

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8 / 22

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